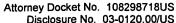


PTO/SB/21 (09-04)
Approved for use through 07/31/2006. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE
Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number. Application Number 10/733,523-Conf. #9060 Filing Date **TRANSMITTAL** December 10, 2003 First Named Inventor **FORM** Kevin L. Beaman Art Unit 1762 (to be used for all correspondence after initial filing) **Examiner Name** D. P. Turocy Attorney Docket Number Total Number of Pages in This Submission 17* 108298718US

	EN	CLOSURES (Check all that	apply)				
Fee Trans	mittal Form	Drawing(s)	After Allowance Communication to TC				
Fee	Attached	Licensing-related Papers	Appeal Communication to Board Appeals and Interferences	of			
Amendme	nt/Reply	Petition	Appeal Communication to TC (Appeal Notice, Brief, Reply Brief)				
After	Final	Petition to Convert to a Provisional Application	Proprietary Information				
Affid	avits/declaration(s)	Power of Attorney, Revocation Change of Correspondence Addre	Status Letter				
Extension	of Time Request	Terminal Disclaimer	X Other Enclosure(s) (please Identify below):				
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Firm Name							
Signature	Dail Vitty						
Printed name	David T. Dutcher						
Date	April 7, 2005	Reg.	. No. 51,638				

^{*} Number of pages does not include the enclosed cited references





(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Beaman et al.

Application No.: 10/733,523

Filed: December 10, 2003

For: METHODS AND SYSTEMS FOR

CONTROLLING TEMPERATURE

DURING MICROFEATURE WORKPIECE PROCESSING, E.G., CVD DEPOSITION

Confirmation No.: 9060

Art Unit: 1762

Examiner: D. P. Turocy

INFORMATION DISCLOSURE STATEMENT (IDS)

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed before the mailing date of a first Office Action on the merits as far as is known to the undersigned (37 CFR 1.97(b)(3)).

A copy of each Non-U.S. Patent and each Non-Patent Literature article listed on the PTO/SB/08 is attached. A copy of the U.S. Patents listed on the PTO/SB/08 has not been provided. A full translation of the non-English language references marked by a check mark ($\sqrt{}$) is enclosed. An abstract is enclosed for all other non-English language

Application No.: 10/733,523 Docket No.: 108298718US

references. Applicant has not verified that the translation or abstract is an accurate representation of the teachings of the non-English reference, though, and reserves the right to demonstrate otherwise.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 50-0665, under Order No. 108298718US.

Dated: April 7, 2005

Respectfully submitted,

David T. Dutcher

Registration No.: 51,638

PERKINS COIE LLP

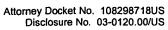
P.O. Box 1247

Seattle, Washington 98111-1247

(206) 359-8000

(206) 359-7198 (Fax)

Attorneys for Applicant





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				Application Number	10/733,523-Conf. #9060		
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Sheet	1	of	13	Attorney Docket Number	108298718US		

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